Optical and Magnetic Microstructures in YIG Ferrite Fabricated by Femtosecond Laser

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Optical and magnetic microstructures are directly fabricated inside a film of cerium-substituted yttrium iron garnet (Ce:YIG) by using a direct femtosecond laser writing. The laser irradiation induces local changes in both optical and magnetic properties of Ce:YIG. A quantitative phase imaging technique proves that the refractive index is increased by 0.015 ± 0.001, which is about 0.7% of Ce:YIG refractive index 2.2 at 632.8 nm. The magneto-optical polar Kerr effect measurement shows that the magnetization property is changed from hard to soft, decreasing the coercivity. Our proposed technique paves the way toward the development of novel three-dimensional magneto-optical devices for optical communication and photonic applications.

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1. Introduction

Femtosecond laser processing has recently been applied to a wide variety of fields, such as laser ablation, lithographic fabrication, and photo-reduction reaction [1-4]. Since this fabrication technique is based on nonlinear multi-photon absorption, it is possible to highly localize only at the focal voxel [5]. Successive chemical or physical reactions can be also confined in a small volume, allowing for both three-dimensional (3D) and sub-diffraction (~100 nm) resolutions in the fabrication [6,7]. By utilizing such unique abilities of the direct laser writing, there have been a number of reports on the formation of 3D micro/nanostructures in transparent materials [8-12] and the development of novel optical functional devices [13-16]. In those studies, although 3D photonic devices were nicely demonstrated based on the refractive index change induced by high-intensity laser pulses, glasses and polymers were mainly used as photo-reactive media and other optical materials are not well studied. To explore versatile applications of the direct laser writing, we here demonstrate femtosecond laser microstructuring of ferrimagnetic ceramic materials.

Specifically, cerium-substituted yttrium iron garnet (Ce,Y3,Fe2O12; Ce:YIG) is used as a photo-reactive medium, and we show that laser irradiation modifies both the optical and magnetic properties of the irradiated Ce:YIG areas [17].

Ce:YIG is one of the most typical ferrimagnetic ceramic materials with a large Faraday rotation and high transparency at infrared wavelengths [18,19]. Because of its excellent magneto-optical performance [20], Ce:YIG has been widely used for nonlinear optical devices, such as Faraday rotators and non-reciprocal waveguide devices to break the time-reversal symmetry of light propagation in photonic integrated circuits (PICs) [21-24]. Although Ce:YIG has many potential applications in PICs, there is one major issue in the process of their fabrication; Ce:YIG is not inherently compatible with PICs consisting of semiconductor optical components. Therefore, an adhesive agent or plasma-assisted direct bonding [25,26] are currently employed for YIG joining, but neither of these processes is sufficient for mechanical, chemical, and thermal durability. On the key issue of how one can incorporate optical and magnetic components into one device, our proposed technique is very appealing because optical and magnetic microstructures can be directly fabricated at one time without any additional process. Furthermore, even complex optical and magnetic structures can be produced, thus being a potential approach to develop novel 3D magneto-optical devices for optical communication and photonic applications [27].

2. Femtosecond laser fabrication in Ce:YIG

Figure 1(a) shows a Ce:YIG wafer used for the experiment. A 1.2-μm-thick single-crystalline Ce:YIG layer was epitaxially grown on a <111> -oriented nonmagnetic garnet substrate ((GdCa)3(GaMgZr)5O12 or SGGG) using magnetron sputtering with a substrate temperature of 690 °C and an argon atmospheric pressure of 0.8 Pa. The sample had a mirror-like surface with a yellowish green color and a relative refractive index of 2.2. Fig. 1(b) depicts the X-ray diffraction spectrum of the Ce:YIG/SGGG wafer. Very sharp Bragg reflections from a Ce:YIG <888> plane are clearly resolved with Kα1 and Kα2 lines, demonstrating high crystallographic quality of the grown Ce:YIG layer. The linear
Fig. 1 (a) 1.2-µm-thick single-crystalline Ce:YIG layer epitaxially grown on a <111>-oriented nonmagnetic garnet (SGGG) substrate. (b) X-ray diffraction spectrum of the Ce:YIG/SGGG wafer and (c) its linear absorption spectrum.

The absorption spectrum of the sample is shown in Fig. 1(c). At the fundamental wavelength of 800 nm, there is no significant absorption, whereas it sharply increases around 400 nm, suggesting that incident femtosecond pulses centered at 800 nm is absorbed by the multi-photon process. In the successive magneto-optical polar Kerr effect measurement, we also confirmed that the as-grown sample exhibited a weak coercive force of 30 Oe.

For all experimental results reported here, a mode-locked Ti:Sapphire femtosecond laser system (Spectra-Physics, Tsunami with Millennia Vs) was used as a light source. The center wavelength, pulse width, and repetition rate were 800 nm, 80 fs, and 82 MHz, respectively. The direct laser writing was carried out using an inverted microscope (Olympus, IX71) where the beam from the laser system was tightly focused into the Ce:YIG layer using an objective lens (40×, NA = 0.9). The focused laser beam was then scanned two-dimensionally (x-y scanning) using a closed-loop-controlled two-axis stage (Sigma Koki, BIOS-402T with FC-501G) with a lateral resolution of 10 nm. The longitudinal (z) position of the laser spot was also controlled by translating the objective lens using a computer-controlled motor stage (Chuo Precision Industrial, MSS-FU) with a resolution of 62.5 nm. The fabrication process was continuously monitored from the backside of the wafer (SGGG side) using a CCD camera (SONY, XC-77).

As shown in Figure 2(a), Ce:YIG was exposed by scanning the laser spot with a constant speed of 100 µm/min for different irradiation powers ranged from 30 to 77 mW. Figs. 2(b) and 2(c) are the reflected and phase-contrast optical microscope images of the sample irradiated by single scanning with a laser power of (i) 30 mW, (ii) 38 mW, (iii) 48 mW, (iv) 60 mW, and (v) 77 mW, and (vi) by multiple (20) scanning with 48 mW. The yellow lines in Fig. 2(c). At moderate powers, the color phase of Ce:YIG was just changed from yellowish to darkish green without any cracking [two thin lines (ii) and (iii) in Fig. 2(c)], suggesting its optical properties were modified by the laser irradiation. The measured width of these two lines, (ii) and (iii), were 750 nm and 1.5 μm, which can be applicable to optical waveguides at infrared wavelengths.

On the other hand, for the laser power of 30 mW or lower, no remarkable change was visible in the optical microscope images.

3. Optical and magnetic characterizations

Our goal in this study is to show that, unlike conventional materials used in femtosecond laser processing, such as glasses and polymers, it is possible to control both the optical and magnetic properties of the exposed Ce:YIG layer. In the following, by quantitatively evaluating the refractive index and magnetization of the exposed Ce:YIG layer, we investigated the effect of laser irradiation on the Ce:YIG properties.

3.1 Quantitative phase imaging

The change in refractive index of the exposed Ce:YIG layer is most important property for optical waveguide applications. To this end, we firstly measured the refractive index change by employing a quantitative phase imaging (QPI) technique [28]. The QPI is a state-of-the-art technology, based on optical interferometry, to map the image of path-length shifts associated with the specimen. This image reveals quantitative information about both the local thickness and refractive index of the structure. By comparing QPI information between the exposed Ce:YIG with that for an as-grown Ce:YIG reference, the intracrytal refractive
In-plane distribution of refractive index change of the exposed Ce:YIG lines measured with a quantitative phase imaging technique. (a) and (b) correspond to (vi) and (ii) in Fig. 2(c), respectively. (c) and (d) are the averaged profiles of the refractive index change in the measured regions of (a) and (b).

The refractive index and the thickness of the non-exposed Ce:YIG was measured beforehand with an ellipsometer and scanning electron microscope. Figures 3(a) and 3(b) are the QPI images measured at a wavelength of 632.8 nm, showing the in-plane distribution of the refractive index change of the fabricated line patterns [(vi) and (ii) in Fig. 2(c)]. From the images, the refractive index of the exposed regions was quantitatively determined and increased by 0.015±0.001 (0.7% of Ce:YIG refractive index). To form an optical waveguide in the Ce:YIG with the refractive index change of 0.7%, a waveguide width has to be 10 μm or more for sufficient optical confinement. On the other hand, the edge-transition width of the fabricated line is less than 500 nm, which is much smaller than the waveguide width, ensuring no unwanted effect on the wave-guiding performance.

3.2 Magneto-optical polar Kerr effect measurement

The change in magnetization of the exposed Ce:YIG layer is another important property for novel magneto-optical device applications. To characterize the magnetic-domain configuration in the Ce:YIG layer, the magneto-optical polar Kerr effect (MOKE) measurement was carried out. Figure 4 shows the schematic magnetization (M-H) curve of the Ce:YIG layer and the corresponding MOKE images measured with different external magnetic field. In Fig. 4(a), the blue curve is for the exposed region, and the red curve is for the non-exposed one, and points (i) – (vi) on the curves correspond to MOKE images (i) - (vi), respectively. Note that this M-H curve was estimated from the magnetic-domain configurations of each MOKE image and is given simply to assist the understanding of the magnetic properties of MOKE images. The MOKE images were measured using a mercury lamp at room temperature with an external magnetic field (parallel to the surface layer). The dark regions are positively magnetized, and the light regions are negatively magnetized.

Firstly, the sample was measured by increasing the magnetic field from -500 Oe to 500 Oe. At an external magnetic field of -470.7 Oe, the entire Ce:YIG layer was negatively magnetized [(i) in Fig. 4]. This means that the Ce:YIG layer, including irradiated regions, was magnetized in the same direction as the magnetic field. As magnetic field increased in the positive direction, the MOKE images changed from (ii) to (iii). The exposed regions easily changed their magnetization in response to the external magnetic field. For the non-exposed regions, on the other hand, the magnetization was maintained. Note that no phase change were observed for the upper two lines because their magnetic property was erased due to the ablation. At an external magnetic field of 495 Oe, the entire Ce:YIG layer was positively magnetized [(iv) in Fig. 4]. Then, the sample was measured by sweeping the magnetic field from the positive side (500 Oe) to the negative side (-500 Oe) and observed that the magnetic-domain showed a hysteric cycling [(v) and (vi) in Fig. 4]. From these results, we concluded that the laser irradiation induced dramatic change in the magnetic property of the Ce:YIG layer from hard to soft, thereby locally controlling the magnetization inside the exposed Ce:YIG layer.

4. Conclusions and outlook

We have demonstrated the femtosecond laser fabrication of optical and magnetic microstructures in Ce:YIG. The laser irradi-
Cated in a Ce:YIG layer on a SGGG substrate: (a) nonreciprocal-phase-shift waveguide and (b) 3D magneto-photonic crystal. Functional 3D micro/nanostructures monolithically fabricated in Ce:YIG and other magneto-optical materials; Magneto-optical elements combined with semiconductor optical components, e.g., optical waveguides, can be incorporated monolithically into one device. For future outlook, two potential applications of the direct laser writing in Ce:YIG and other magneto-optical materials; Magneto-optical elements combined with semiconductor optical components, e.g., optical waveguides, can be incorporated monolithically into one device.

For future outlook, two potential applications of the direct laser writing in Ce:YIG are discussed in Figure 5. A nonreciprocal-phase-shift waveguide [Fig. 5 (a)] can be fabricated by simply scanning a laser spot in magneto-optical materials [31]. The upper cladding layer on the waveguide is left non-exposed to exhibit a large residual magnetization. The resultant device works as a nonreciprocal-phase-shift waveguide for an integrated optical isolator in the form of a Mach-Zehnder interferometer. A magneto-photic crystal (MPC) [Fig. 5 (b)] can also be constructed by simply writing 3D micro/nanostructures to form a spatially periodic refractive-index change inside the Ce:YIG. The magnetization can be controlled space-periodically with an appropriate external magnetic field. As a result, a periodic optical and magnetic structure can be realized in the Ce:YIG layer. With this magneto-photon crystal, more flexible band engineering can be achieved. Our new fabrication technique presented here will open new fields in the technology of magneto-optical devices and contribute to the development of novel 3D magneto-optical devices for optical communication and photonic applications.

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